L Number	Hits	Search Text	DB	Time stamp
15	2	6058125.URPN.	USPAT	2004/03/04 16:16
16	1	"5278926".PN.	USPAT	2004/03/04 16:17
20	7	6037189.URPN.	USPAT	2004/03/04 16:17
21	11645	(372/43,45,46,50).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/04 16:24
22	4239	((372/43,45,46,50).CCLS.) and (stripe ridge) and semiconductor	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/04 16:24
23	3758	(((372/43,45,46,50).CCLS.) and (stripe ridge) and semiconductor) and substrate	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/04 16:25
24	260	((((372/43,45,46,50).CCLS.) and (stripe ridge) and semiconductor) and substrate) and (edge near3 emitt$5)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/04 16:26
25	1911	((((372/43,45,46,50).CCLS.) and (stripe ridge) and semiconductor) and substrate) and (stripe ridge) with active	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/04 16:26
26	130	(((((372/43,45,46,50).CCLS.) and (stripe ridge) and semiconductor) and substrate) and (edge near3 emitt$5)) and (((((372/43,45,46,50).CCLS.) and (stripe ridge) and semiconductor) and substrate) and (stripe ridge) with active)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/04 16:26
-	4405	(semiconductor near3 laser) same (stripe ridge mesa)	USPAT; EPO; JPO; IBM_TDB	2003/08/14 13:02
-	2371	((semiconductor near3 laser) same (stripe ridge mesa)) and 372/$.ccls.	USPAT; EPO; JPO; IBM_TDB	2003/08/20 15:14
-	112	(((semiconductor near3 laser) same (stripe ridge mesa)) and 372/$.ccls.) and edge near2 emit$4	USPAT; EPO; JPO; IBM_TDB	2003/08/12 18:44
-	7	6324326.URPN.	USPAT	2003/08/12 18:20
-	18	("4161944" | "4179187" | "4212660" | "4705351" | "4886538" | "4901324" | "4941726" | "5119460" | "5166940" | "5265177" | "5422897" | "5455879" | "5530710" | "5659644" | "5710789" | "5774484" | "5864644" | "5940557").PN.	USPAT	2003/08/12 18:22
-	4	6134368.URPN.	USPAT	2003/08/12 18:31
-	4	("5284791" | "5360763" | "5382543" | "5717710").PN.	USPAT	2003/08/12 18:33
-	2	nichia.as. and (edge with emit$4) and laser	USPAT; EPO; JPO; IBM_TDB	2003/08/12 18:46
-	212	nichia.as. and laser	USPAT; EPO; JPO; IBM_TDB	2003/08/12 18:46
-	70	(nichia.as. and laser) and (ridge stripe)	USPAT; EPO; JPO; IBM_TDB	2003/08/12 18:50
-	11910	372/43-50.ccls.	USPAT; EPO; JPO; IBM_TDB	2003/08/12 19:18
-	665	372/43-50.ccls. and (edge with emit$5)	USPAT; EPO; JPO; IBM_TDB	2003/08/12 18:50
-	281	(372/43-50.ccls. and (edge with emit$5)) and (ridge stripe)	USPAT; EPO; JPO; IBM_TDB	2003/08/12 18:50

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-	192	((372/43-50.ccls. and (edge with emit$5)) and (ridge stripe)) not ((((semiconductor near3 laser) same (stripe ridge mesa)) and 372/$.ccls.) and edge near2 emit$4)	USPAT; EPO; JPO; IBM_TDB	2003/08/12 18:51
-	80	(((372/43-50.ccls. and (edge with emit$5)) and (ridge stripe)) not ((((semiconductor near3 laser) same (stripe ridge mesa)) and 372/$.ccls.) and edge near2 emit$4)) and (film "Si0.sub.2" "TiO" "SiO")	USPAT; EPO; JPO; IBM_TDB	2003/08/12 18:52
-	1	(((372/43-50.ccls. and (edge with emit$5)) and (ridge stripe)) not ((((semiconductor near3 laser) same (stripe ridge mesa)) and 372/$.ccls.) and edge near2 emit$4)) and (shad$4 with film)	USPAT; EPO; JPO; IBM_TDB	2003/08/12 18:52
-	5	6034983.URPN.	USPAT	2003/08/12 19:01
-	13	("5011550" | "5079184" | "5130269" | "5227328" | "5229319" | "5266127" | "5300186" | "5399522" | "5424243" | "5574289" | "5657338" | "5787106" | "5790578").PN.	USPAT	2003/08/12 19:03
-	219	372/43-50.ccls. and (edge with emitting) and (stripe ridge) and active and semiconductor and substrate	USPAT; EPO; JPO; IBM_TDB	2003/08/12 19:40
-	2	372/43-50.ccls. and (edge with emitting) and (stripe ridge) and (shad$3 with film)	USPAT; EPO; JPO; IBM_TDB	2003/08/12 19:48
-	4191	(372/43-50).CCLS.	USPAT	2003/08/14 13:03
-	2807	(372/49,9,50,108,101).CCLS.	USPAT	2003/08/14 13:03
-	1172	((372/49,9,50,108,101).CCLS.) and lens	USPAT	2003/08/14 13:04
-	881	((372/43-50).CCLS.) and lens	USPAT	2003/08/14 14:13
-	7	5966399.URPN.	USPAT	2003/08/14 13:50
-	2	("5426657" | "5838715").PN.	USPAT	2003/08/14 13:51
-	7	5553089.URPN.	USPAT	2003/08/14 14:03
-	3	("5081639" | "5086431" | "5212706").PN.	USPAT	2003/08/14 14:03
-	655	(((372/49,9,50,108,101).CCLS.) and lens) not (((372/43-50).CCLS.) and lens)	USPAT	2003/08/14 14:25
-	2483	372/43-50.ccls. and (ridge stripe mesa)	USPAT	2003/08/14 14:25
-	486	(372/43-50.ccls. and (ridge stripe mesa)) and lens	USPAT	2003/08/14 14:26
-	0	((372/43-50.ccls. and (ridge stripe mesa)) and lens) not (((((372/43-50).CCLS.) and lens) (((372/49,9,50,108,101).CCLS.) and lens))	USPAT	2003/08/14 14:30
-	1	6167070.pn.	USPAT	2003/08/14 14:31
-	1	6037189.pn.	USPAT	2003/08/14 15:02
-	1205	(372/43-50.ccls. and (ridge stripe mesa)) and (film passivation)	USPAT	2003/08/14 15:04
-	1165	372/46.ccls. and (stripe ridge)	USPAT	2003/08/14 15:04
-	666	(372/46.ccls. and (stripe ridge)) and (film passivation)	USPAT	2003/08/14 15:06
-	50	(372/46.ccls. and (stripe ridge)) and (passivation)	USPAT	2003/08/14 15:26
-	9	(372/46.ccls. and (stripe ridge)) and (SiO TiO) near3 (layer film)	USPAT	2003/08/14 15:26
-	26	(US-6463087-$ or US-6134368-$ or US-6374028-$ or US-6455342-$ or US-6327288-$ or US-6034983-$ or US-6219366-$ or US-6465269-$ or US-5790578-$ or US-5665985-$ or US-6586776-$ or US-6167070-$ or US-6122417-$ or US-6058125-$ or US-6037189-$ or US-5970081-$ or US-5966399-$ or US-5835517-$ or US-5553089-$ or US-5428227-$ or US-5457569-$ or US-6472691-$ or US-5659565-$ or US-5640410-$ or US-5333141-$ or US-4813054-$).did.	USPAT	2003/08/14 15:52
-	1481	((semiconductor near3 laser) same (stripe ridge mesa)) and 372/$.ccls.	USPAT	2003/08/20 15:15
-	233	(((semiconductor near3 laser) same (stripe ridge mesa)) and 372/$.ccls.) and nitride	USPAT	2003/08/20 15:19
-	198	((((semiconductor near3 laser) same (stripe ridge mesa)) and 372/$.ccls.) and nitride) and (film dielectric passivation SiO TiO)	USPAT	2003/08/20 15:20

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